



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 4334**
Junichiro YOSHIOKA et al. : Docket No. 2001_1740
Serial No. 09/990,387 : Group Art Unit 1753
Filed November 23, 2001 : Examiner Arun S. Phasge
SEMICONDUCTOR WAFER HOLDER AND ELECTROPLATING SYSTEM FOR PLATING A SEMICONDUCTOR WAFER **Mail Stop: Amendment**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a two month extension of time to respond to the communication of March 24, 2005.

The fee of \$450.00 is

☒ submitted herewith.

☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.

☐ Small entity status of this application is established by a Small Entity Status Assertion which

☐ is enclosed.

☐ has been previously submitted.

Respectfully submitted,

Junichiro YOSHIOKA et al.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

By

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